

30827

CPA/1765#
#13

Docket No. 8733.154.00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Jin JANG et al.

GAU: 1765

SERIAL NO: 09/350,313

EXAMINER : R. Kunemund

FILED: July 9, 1999

FOR: METHOD OF CRYSTALLIZING AMORPHOUS SILICON LAYER AND
CRYSTALLIZING APPARATUS THEREOFREQUEST FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

It is hereby requested that a 3-month extension of time be granted to April 16, 2002 for

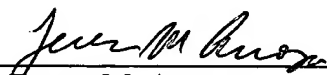
- ☐ filing a response to the Official Action dated:
- ☐ responding to the requirements in the Notice of Allowability dated:
- ☐ filing the Formal Drawings. The Issue Fee due been timely filed.
- ☐ responding to the Notice to File Missing Parts of Application dated:
- ☐ filing a Notice of Appeal. A timely response to the final rejection, due has been filed.
- ☒ filing an Appeal Brief. A Notice of Appeal was filed on: 11/16/01

The required fee of \$920.00 is enclosed herewith by check and any further charges may be made against the Attorney of Record's Deposit Account No. 50-0911. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

LONG ALDRIDGE &
NORMAN LLPDate: April 16, 2002

Sixth Floor
701 Pennsylvania Avenue, N.W.
Washington, D.C. 20004
Tel. (202) 624-1200
Fax. (202) 624-1298


Teresa M. Arroyo
Registration No. 50,015

04/17/2002 HDEHESS1 00000032 09350313

04 FC:117

920.00 DP

RECEIVED
APR 19 2002
TC 1700